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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/796,278	03/10/2004	Sadao Mori	029116.53329US	9383
23911 7590 04/30/2008 CROWELL & MORING LLP INTELLECTUAL PROPERTY GROUP			EXAMINER	
			HEINRICH, SAMUEL M	
P.O. BOX 14300 WASHINGTON, DC 20044-4300			ART UNIT	PAPER NUMBER
			3742	
			MAIL DATE	DELIVERY MODE
			04/30/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary

Application No.	Applicant(s)	
10/796,278	MORI ET AL.	
Examiner	Art Unit	
Samuel M. Heinrich	3742	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS.

- WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.
- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed

 If NO pe Failure t Any repl 	riof for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MCNIT-IS from the mailing date of this communication or poly within the set or extended period for reply will be the application to become ABANDONED SIS U.S.C. § 133), y received by the Office later than three months after the mailing date of this communication, even if timely filled, may reduce any statent term disjutance. See 37 OFF 1.704(b).
Status	
1)□ R	esponsive to communication(s) filed on
2a) <u></u> ⊤	his action is FINAL. 2b)⊠ This action is non-final.
3)□ S	ince this application is in condition for allowance except for formal matters, prosecution as to the merits is
cl	osed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.
Disposition	n of Claims
4)⊠ C	laim(s) <u>2-5</u> is/are pending in the application.
4a) Of the above claim(s) is/are withdrawn from consideration.
5)□ C	laim(s) is/are allowed.
6)⊠ C	laim(s) <u>2-5</u> is/are rejected.
7)□ C	laim(s) is/are objected to.
8)□ C	laim(s) are subject to restriction and/or election requirement.
Application	n Papers
9)□ Th	e specification is objected to by the Examiner.
10)⊠ Tr	ne drawing(s) filed on 10 March 2004 is/are: a)⊠ accepted or b)□ objected to by the Examiner.
A	oplicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
R	eplacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d
11)□ Tr	e oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.
Priority un	der 35 U.S.C. § 119
12)⊠ Ac	knowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a)⊠	All b) Some * c) None of:
1.	Certified copies of the priority documents have been received.
2.	Certified copies of the priority documents have been received in Application No
3.	Copies of the certified copies of the priority documents have been received in this National Stage

Attachment(s)

- 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) Information Disclosure Statement(s) (FTO/SE/08)
- Paper No(s)/Mail Date _

- 4) Interview Summary (PTO-413)
- Paper No(s)/Mail Date. 5) Notice of Informal Patent Application
 - 6) Other:

application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. Application/Control Number: 10/796,278

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DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 2-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant's Admitted Prior Art (AAPA) in view of US20020163730A1 to Sugiyama et al in view of USPN 6,977,775 to Sasaki et al in view of USPN 6,804,269 to Lizotte et al in view of US20040264353A1 to Kitahara et al.

AAPA discloses (Specification, Background Art [0002]-[0009]) well known beam splits and well known multiple optical systems associated with one machining lens so that machining speed is improved.

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Sugiyama et al disclose (Front Page) producing a superior image formation using split and subsequently recombined beams. The polarization rotation (column 15, lines 41-52) is 90 degrees.

Sasaki et al disclose (Figure 8) beam splitting devices producing multiple splits.

Lizotte et al disclose (Claims 14 and 16) spacing of prism pairs.

Kitahara et al describe [0084] well known half mirror formed within a beam splitter prism.

The use of the multiple beam splitters and polarization rotation would have been obvious at the time applicant's invention was made to a person having ordinary skill in the art because the combined beams provide more uniform crystallization.

Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant's Admitted Prior Art (AAPA) in view of US20020163730A1 to Sugiyama et al in view of USPN 6,977,775 to Sasaki et al in view of USPN 6,804,269 to Lizotte et al in view of US20040264353A1 to Kitahara et al as applied to claim 2 above, and further in view of USPN 5,825,043 to Suwa.

Suwa describe (column 8, line 25) well known relay optical system and the use thereof would have been obvious at the time applicant's invention was made to a person having ordinary skill in the art because it provides capability for monitoring.

Claims 2-5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant's Admitted Prior Art (AAPA) in view of USPN 6,650,480 to Tanaka in view of USPN 6,977,775 to Sasaki et al in view of USPN 6,804,269 to Lizotte et al in view of US20040264353A1 to Kitahara et al.

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AAPA discloses (Specification, Background Art [0002]-[0009]) well known beam splits and well known multiple optical systems associated with one machining lens so that machining speed is improved.

Tanaka disclose (Front Page) uniform annealing using split and subsequently recombined beams. The beam polarization is perpendicular (column 5, line 58 through column 6, line 26).

Sasaki et al disclose (Figure 8) beam splitting devices producing multiple splits.

Lizotte et al disclose (Claims 14 and 16) spacing of prism pairs.

Kitahara et al describe [0084] well known half mirror formed within a beam splitter prism.

The use of the multiple beam splitters and polarization rotation would have been obvious at the time applicant's invention was made to a person having ordinary skill in the art because the combined beams provide more uniform crystallization.

Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant's Admitted Prior Art (AAPA) in view of USPN 6,650,480 to Tanaka in view of USPN 6,977,775 to Sasaki et al in view of USPN 6,804,269 to Lizotte et al in view of US20040264353A1 to Kitahara et al as applied to claim 2 above, and further in view of USPN 5,825,043 to Suwa.

Suwa describe (column 8, line 25) well known relay optical system and the use thereof would have been obvious at the time applicant's invention was made to a person having ordinary skill in the art because it provides capability for monitoring.

Response to Arguments

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Applicant's arguments with respect to claims have been considered but are moot in view of the new ground(s) of rejection.

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel M. Heinrich whose telephone number is 571-272-1175. The examiner can normally be reached on M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tu B. Hoang can be reached on 571-272-4780. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Samuel M Heinrich/ Primary Examiner, Art Unit 3742